



INFORMATION DISCLOSURE STATEMENT

Applicant	:	Van Kesteren et al.
App. No.	:	10/713,543
Filed	:	November 14, 2003
For	:	HEAT TREATMENT APPARATUS WITH TEMPERATURE CONTROL SYSTEM
Examiner	:	Unknown
Group Art Unit	:	Unknown

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed is form PTO-1449 listing 60 references. Copies of disclosed U.S. patents and/or publications are not included pursuant to PTO waiver of the requirement under 37 C.F.R. § 1.98(a)(2)(i) for applications filed after June 30, 2003. Copies of other references, if listed, are enclosed.

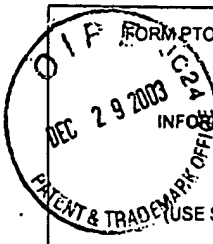
This Information Disclosure Statement is being filed with an RCE or within three months of the filing date of this application and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1), (b)(2), or (b)(4).

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

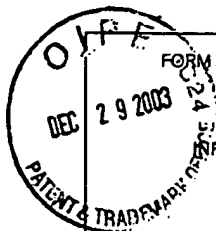
Dated: December 22, 2003 By: Adeel Syed Akhtar

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 FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (USE SEVERAL SHEETS IF NECESSARY)	ATTY. DOCKET NO. ASMINT.058AUS	APPLICATION NO. 10/713,543
	APPLICANT Van Kesteren et al.	
	FILING DATE November 14, 2003	GROUP Unknown

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
<i>JS</i>	1.	3,947,236	3/30/76	Lasch, Jr.			
	2.	4,346,433	8/24/82	Rutledge			
	3.	4,385,362	5/24/83	Arcara			
	4.	4,630,189	12/16/86	Ohmori et al.			
	5.	4,639,853	1/27/87	Rake et al.			
	6.	4,860,687	8/29/89	Frijlink			
	7.	4,495,024	01/22/85	Bok			
	8.	4,560,590	12/24/85	Bok			
	9.	4,575,408	03/11/86	Bok			
	10.	4,975,561	12/04/90	Robinson, et al.			
	11.	5,178,639	01/1993	Nishi			
	12.	5,180,273	01/1993	Sakaya et al.			
	13.	5,314,848	05/24/94	Yasui, et al.			
	14.	5,332,442	07/26/94	Kubodera, et al.			
	15.	5,407,449	04/18/95	Zinger			
	16.	5,411,076	05/95	Matsunaga et al.			
	17.	5,414,244 A1	05/95	Imahashi			
	18.	5,430,271	07/04/95	Orgami, et al.			
	19.	5,431,700	07/95	Sloan			
	20.	5,635,409	6/3/97	Moslehi			
	21.	5,646,313	11/1995	Ohsawa			
	22.	5,650,082	07/22/97	Anderson			
	23.	5,790,750	08/04/98	Anderson			
	24.	5,855,681	01/1999	Maydan et al.			
	25.	5,997,588	12/7/99	Goodwin et al.			
	26.	6,001,175	12/14/99	Maruyama et al.			
	27.	6,018,616	01/25/00	Schaper			

EXAMINER <i>Shawn Tena? Juguas</i>	DATE CONSIDERED <i>3/3/05</i>
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.	



FORM PTO-1449

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APPLICANT
Van Kesteren et al.FILING DATE
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Unknown

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
<i>JS</i>	28.	6,064,799	05/16/00	Anderson, et al.			
	29.	6,072,163 A1	06/00	Armstrong et al.			
	30.	6,080,969	06/27/00	Goto, et al.			
	31.	6,097,005	08/01/00	Akimoto			
	32.	6,099,056	8/8/00	Siniaguine et al.			
	33.	6,111,225	08/29/00	Ohkase, et al.			
	34.	6,128,586	10/3/00	Pfeiffer			
	35.	6,183,565 B1	02/06/01	Granneman, et al.			
	36.	6,207,936 B1	03/27/01	de Waard, et al.			
	37.	6,215,106	04/01	Boas et al.			
	38.	6,222,164 B1	4/24/01	Stoddard et al.			
	39.	6,234,788 B1	05/01	Lec			
	40.	6,275,744 B1	08/01	Yoshida			
	41.	6,329,304 B1	12/11/01	Kuznetsov, et al.			
	42.	6,373,033 B1	4/16/02	De Waard et al.			
	43.	6,411,944 B1	6/25/02	Ulyanov			
	44.	6,496,749 B1	12/17/02	Yamaguchi et al.			
	45.	6,501,998 B1	12/31/02	Pfeiffer			
	46.	2003/0092231 A1	5/15/03	Granneman et al.			
	47.	2003/0209200	11/13/03	Kuznetsov et al.			
	48.	2003/0209327 A1	11/13/03	Kuznetsov, et al.			
<i>JS</i>	49.	2003/0027094 A1	2/6/03	Storm et al.			

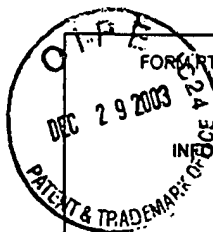
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Shawntena Igua

DATE CONSIDERED

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FOREIGN PATENT DOCUMENTS								
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
<i>[Signature]</i>	50.	JP 02034915A	2/5/90	Japan			Abstract	
<i>[Signature]</i>	51.	JP 04078130A	3/12/92	Japan			Abstract	
<i>[Signature]</i>	52.	JP 61294812A	12/25/86	Japan			Abstract	
<i>[Signature]</i>	53.	JP 62021237A	1/29/87	Japan			Abstract	
<i>[Signature]</i>	54.	JP 08236533	09/13/96	Japan			Abstract	
<i>[Signature]</i>	55.	JP 10321505	12/04/98	Japan			Abstract	
<i>[Signature]</i>	56.	WO 00/42638	07/20/00	PCT			N/A	
<i>[Signature]</i>	57.	WO 00/68977	11/16/00	PCT			N/A	
<i>[Signature]</i>	58.	WO 98/01890	1/15/98	PCT			N/A	
<i>[Signature]</i>	59.	WO 90/13687	11/15/90	PCT			N/A	

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)
<i>[Signature]</i>	60. Porter, et al., Fast-ramp rapid vertical processor for 300-mm Si wafer processing. SPIE vol 3507, September 1998, p 42-53.

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EXAMINER <i>Shawntera Sugua</i>	DATE CONSIDERED <i>3/3/05</i>
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